# **Evaluation of Mechanical Properties of Electroplated Nickel Using Micro-Compression Test** 家东工業大家 Takashi Nagoshi, X Tso-Fu Mark Chang, Tatsuo Sato, Masato Sone 130th Anniversary in 2011 Precision and Intelligence Laboratory, Tokyo Institute of Technology, Japan









✓Increased desorption of H<sub>2</sub> bubble from cathode Void and defect free ✓ Periodic on/off at the surface of the cathode Grain refinement



Gas and liquid Critical point Supercritical fluid

Enhanced mechanical properties

# EXPERIMENTAL PROBEDURE

## Fabrication of Compression Pillar By FIB



Materials
Substrate
Cathode : Cu substrates
Anode: Ni substrates
Additive Free Watts Bath
➢ NiSO₄●6H₂O (300 g/l)
$\geq$ NiCl <sub>2</sub> •6H <sub>2</sub> O (50 g/l)
> H <sub>3</sub> BO <sub>3</sub> (50 g/l)
Surfactant
polyoxyethylene lauryl ether
(C <sub>12</sub> H <sub>25</sub> (OCH <sub>2</sub> CH <sub>2</sub> ) <sub>15</sub> OH)
Pretreatment
Degreecing $10 \text{ wt}^{0}$ Acc

- Degreasing, 10 wt% Ace clean solution for 1min
- Remove oxide layer, 10 wt% HCl solution for 10 sec

# Electroplating With Sc-CO<sub>2</sub>

### **Plating Condition**

	ESCE	High Pressure Electroplating (HPE)	
Temperature	323 K		
CO <sub>2</sub> vol%	20 vol%		
Current Density	2 A/dm <sup>2</sup>		
Pressure	15 MPa	6 MPa	
Agitation	On	Off	

To prove how much would the emulsified Sc-CO<sub>2</sub> affect the structure and properties

# RESULTS & DISCUSSION

# Scanning Ion Microscope (SIM) Observation



ESCE Single Cristal (SC) HPE Image contrast represents difference in crystal orientation

ESCE	Grains are finer than the SIM resolution
HPE	Columnar grains with diameter of 2 $\mu m$
SC	Single crystal

Equiaxed nanocrystalline nickel were obtained by

periodic on/off characteristics in ESCE

## **TEM Observations of ESCE Nickel**

# **SEM Observation After Deformation**



ESCE Nickel

#### Yield strength of ESCE Nickel is 10 times higher than SC &





(MPa) 3000 stress True **HPE** Nickel 1000 SC Nickel Plastic true strain (%)

5 times higher than HPE

Compressive strength exceeds 3500 MPa in micro-compression Cracks or failure are absent up to 9 % of permanent strain

ESCE is a good candidate to improve mechanical properties of plated film

# EUNELIS UNS

4000

- Due to the periodic on/off characteristics in ESCE by bouncing micelles on the cathode, grain size decreased to 8 nm.
- As grain size decreased from 2 µm to 8 nm, yield stress increased by a factor of around five. And maximum stress for ESCE nickel reaches 3.5 GPa without any crack or failure up to 9% of permanent strain.